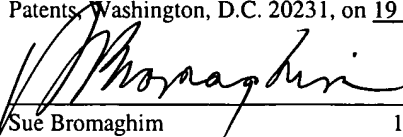


CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 19 November 2002.


Sue Bromaghin

19 November 2002

Attorney Docket No. LTWD 1001-1
(fka PACT 1001-1)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): GARY POWELL

Application No. 09/631,271
Confirmation No. 8514

Filed: 2 August 2000

Title: **Inductively Coupled Plasma
Spectrometer for Process
Diagnostics and Control**

Art Unit: 2881

Examiner: Johnnie L. Smith

Customer No. 22470

Assistant Commissioner for Patents
Washington, DC 20231
Sir:

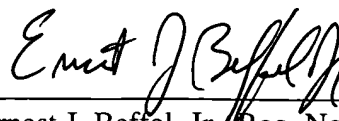
TRANSMITTAL OF RESPONSE TO OFFICIAL ACTION

Enclosed for filing in the subject application are the following documents:

- [X] **Response to Office Action**, for which no fee is due; and
- [X] **Information Disclosure Statement**, PTO Form 1449 and 6 references, the fee for which is enclosed (Check No. 2025 in the amount of \$180).

Authorization is given to charge the Deposit Account of the undersigned (Account No. 50-0869 / LTWD 1001-1), or credit any overpayment thereto, any other fees associated with this document.

Respectfully submitted,



Ernest J. Beffel, Jr., Reg. No. 43,489

Dated: 19 November 2002

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